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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/697,618	10/29/2003	James O'Neil	200312535-1	7287	
22879	7590 12/05/2006	EXAMINER			
	PACKARD COMPA	MCDONALD, RODNEY GLENN			
	400, 3404 E. HARMO	ART UNIT	PAPER NUMBER	•	

1753

DATE MAILED: 12/05/2006

Please find below and/or attached an Office communication concerning this application or proceeding.

		Applicati	on No.	Applicant(s)				
Office Action Summary		10/697,6	18	O'NEIL ET AL.				
		Examine	•	Art Unit				
		Rodney C	i. McDonald	1753				
	The MAILING DATE of this communic	cation appears on the	e cover sheet with	the correspondence a	ddress			
Period fo	• •		=\\5\5	NEW OR THEFTY	00) 541/0			
WHIC - Exter after - If NO - Failu Any r	ORTENED STATUTORY PERIOD FO CHEVER IS LONGER, FROM THE MA resions of time may be available under the provisions of SIX (6) MONTHS from the mailing date of this commu- period for reply is specified above, the maximum state re to reply within the set or extended period for reply we reply received by the Office later than three months afted and patent term adjustment. See 37 CFR 1.704(b).	AILING DATE OF THE AILING DATE OF THE AILING PRINCE	HIS COMMUNICA ent, however, may a rep ill expire SIX (6) MONTA dication to become ABA	ATION. lly be timely filed HS from the mailing date of this NDONED (35 U.S.C. § 133).				
Status								
1) 又	Responsive to communication(s) filed	d on <u>30 September :</u>	<u>2006</u> .					
	•	b)⊠ This action is r						
3)								
	closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.							
Dispositi	on of Claims							
4)⊠	Claim(s) 1-66 is/are pending in the ap	oplication.						
-	4a) Of the above claim(s) <u>38-66</u> is/are withdrawn from consideration.							
5)	Claim(s) is/are allowed.							
6)⊠	Claim(s) 1-37 is/are rejected.							
7)	Claim(s) is/are objected to.		-					
8)□	Claim(s) are subject to restrict	ion and/or election r	equirement.					
Applicati	ion Papers							
9)	The specification is objected to by the	Examiner.						
<i>,</i> —	The drawing(s) filed on is/are:		objected to by	y the Examiner.				
	Applicant may not request that any object	tion to the drawing(s)	oe held in abeyanc	e. See 37 CFR 1.85(a).				
	Replacement drawing sheet(s) including	the correction is requi	ed if the drawing(s) is objected to. See 37 (CFR 1.121(d).			
11)	The oath or declaration is objected to	by the Examiner. N	ote the attached	Office Action or form P	PTO-152.			
Priority (ınder 35 U.S.C. § 119							
	Acknowledgment is made of a claim f ☐ All b)☐ Some * c)☐ None of:	or foreign priority un	der 35 U.S.C. §	119(a)-(d) or (f).				
۵,	1. Certified copies of the priority of	documents have bee	en received.					
	2. Certified copies of the priority of			plication No				
	3. Copies of the certified copies of	of the priority docum	ents have been r	eceived in this Nationa	l Stage			
	application from the Internation	nal Bureau (PCT Ru	le 17.2(a)).					
* 5	See the attached detailed Office action	for a list of the cert	ified copies not re	eceived.				
Attachmen								
	e of References Cited (PTO-892) of Draftsperson's Patent Drawing Review (PT	ГО-948)		mmary (PTO-413) /Mail Date				
3) 🔯 Infor	mation Disclosure Statement(s) (PTO/SB/08) or No(s)/Mail Date 10/03, 12/05.			ormal Patent Application				

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DETAILED ACTION

Election/Restrictions

Applicant's election of Group I, Claims 1-37 in the reply filed on 9-30-06 is acknowledged. Because applicant did not distinctly and specifically point out the supposed errors in the restriction requirement, the election has been treated as an election without traverse (MPEP § 818.03(a)).

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

Claims 1, 2, 5, 6, 9, 15, 16, 20, 21, 24, 31, 32, 34, 35 and 36 are rejected under 35 U.S.C. 103(a) as being unpatentable over Barnett et al. (U.S. Pat. 5,395,704) in view of Montcalm et al. (U.S. Pat. 6,668,207).

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Regarding claim 1, Barnett et al. teach a method of forming a thin film fuel cell electrode. (See Abstract) Barnett et al. teach providing a substrate and at least one deposition device. (Column 3 lines 56-68; Column 4 lines 1-38) A film is deposited that has a porous property since the films deposited have densities of from 75% to >85%. (Column 4 lines 62-65) The position of the substrate can be varied by rotating the substrate with respect to the targets. (Column 4 lines 29-33)

Regarding claim 15, Barnett et al. teach providing at least first and second deposition devices. (Column 3 lines 56-68; Column 4 lines 1-38)

Regarding claim 31, Barnett et al. teach utilizing second and third deposition devices. (Column 3 lines 56-68; Column 4 lines 1-38)

Regarding claim 34, the electrode comprises an anode. (Column 5 lines 37-57)

Regarding claim 35, the anode can be Ni-YSZ. (Column 5 lines 50-53)

Regarding claim 36, the electrode comprises a cathode. (Column 5 lines 37-57)

The differences between Barnett et al. and the present claims is that the deposition characteristic profile for the film is not discussed (Claim 1), varying the relative position of the substrate with respect to at least one axis in order to achieve the deposition characteristic profile is not discussed (Claim 1), the varying of the power is not discussed (Claims 2, 16), advancing the substrate along a substrate advancement path is not discussed (Claims 5, 20), varying the speed is of the substrate is not discussed (Claims 6, 21, 32) and traversing the substrate back and forth is not discussed (Claims 9, 24).

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Regarding the deposition characteristic profile for the film and varying the relative position of the substrate with respect to at least one axis in order to achieve the deposition characteristic profile (Claim 1), Montcalm teach a method for achieving a selected thickness profile and varying the relative position of the substrate to at least one axis in order to achieve a deposition characteristic profile by controlling the velocity and spinning the substrate as the substrate sweeps across the source. (See Abstract; Column 7 lines 8-15; Column 7 lines 46-51)

Regarding claim 2, 16, Montcalm teach controlling the power to control the desired thickness profile. (Column 7 lines 8-15)

Regarding claims 5, 20, Montcalm teach advancing the substrate along a substrate advancement path. (Column 7 lines 37-45)

Regarding claims 6, 21, 32, Montcalm teach that the speed of the substrate can be varied to control the thickness profile. (Column 7 lines 8-15)

Regarding claims 9, 24, Montcalm teach that the substrate can be traversed back and forth. (Column 7 lines 37-39)

The motivation for utilizing the features of Montcalm is that it allows for producing highly uniform films. (See Abstract)

Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to have modified Barnett et al. by utilizing the features of Montcalm et al. because it allows for producing uniform films.

Claims 3 and 17 are rejected under 35 U.S.C. 103(a) as being unpatentable over Barnett et al. in view of Montcalm et al. as applied to claims 1, 2, 5, 6, 9, 15, 16, 20, 21,

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24, 31, 32, 34, 35 and 36 above, and further in view of Tsai et al. "Bias sputtered deposition of dense Yttria-Stabilized Zirconia Films on Porous Substrates", J. Electrochem. Soc., Vol. 142, No. 9, September 1995 pp. 3084-3087.

The difference not yet discussed is the varying of the bias to the substrate. (Claims 3, 17)

Regarding claims 3 and 17, Tsai et al. teach controlling the bias of the substrate during deposition in order to control the structure of the film. (See Abstract; Page 3085)

The motivation for utilizing the features of Tsai et al. is that it allows for controlling the structure of the film. (Page 3085)

Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to have utilized the features of Tsai et al. because it allows for controlling the structure of the film.

Claims 4 and 19 are rejected under 35 U.S.C. 103(a) as being unpatentable over Barnett et al. in view of Montcalm et al. as applied to claims 1, 2, 5, 6, 9, 15, 16, 20, 21, 24, 31, 32, 34, 35 and 36 above, and further in view of Ueda (Japan 63-195263).

The difference not yet discussed is the varying of the magnetic field. (Claims 4, 19)

Regarding claims 4, 19, Ueda teach utilizing a varying magnetic flux density during deposition to obtain a homogenous thin film. (See Abstract)

The motivation for utilizing the features of Ueda is that it allows for achieving a homogenous thin film. (See Abstract)

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Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to have utilized the features of Ueda because it allows for achieving a homogenous thin film.

Claims 7, 8, 10, 11, 18, 22, 25, 26, 30 and 33 are rejected under 35 U.S.C. 103(a) as being unpatentable over Barnett et al. in view of Montcalm et al. as applied to claims 1, 2, 5, 6, 9, 15, 16, 20, 21, 24, 31, 32, 34, 35 and 36 above, and further in view of Kobayashi (Japan 05-021347).

The difference not yet discussed is the varying of the distance (Claims 7, 18, 22, 30), the varying of the speed (Claim 8), varying the distance in multiple directions is not discussed (Claims 10, 25), varying the speed is not discussed (Claims 11, 26) and varying the substrate advancement path is not discussed (Claim 33).

Regarding claims 7, 18, 22, 30, Kobayashi et al. teach varying the distance between the deposition source and the substrate so that the composition of the film can be the same as when the film was first deposited. (See Abstract)

Regarding claim 8, Montcalm already discussed above teach varying the speed of the substrate for depositing a uniform film. (See Montcalm discussed above)

Regarding claims 10, 25, since Montcalm teach rotating the substrate and Kobayashi teach changing the distance between substrate and deposition source the distance is varied in multiple directions between the substrate and the deposition. (i.e. in the horizontal and vertical directions.) (See Montcalm and Kobayashi discussed above)

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Regarding claims 11, 26, Montcalm is discussed above and teach varying the speed of the substrate. (See Montcalm discussed above)

Regarding claim 33, since Montcalm teach rotating the substrate and Kobayashi teach changing the distance between substrate and deposition source the substrate advancement path is varied. (See Montcalm and Kobayashi discussed above)

The motivation for utilizing the features of Kobayashi is that it allows for controlling the composition of the film. (See Kobayashi et al. discussed above)

Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to have utilized the features of Kobayashi et al. because it allows for controlling the composition of the film.

Claims 23 are rejected under 35 U.S.C. 103(a) as being unpatentable over Barnett et al. in view of Montcalm et al. and further in view of Kobayashi et al. as applied to claims 1, 2, 5, 6, 7, 8, 9, 10, 11, 15, 16, 18, 20, 21, 22, 24, 26, 30, 31, 32, 33, 34, 35 and 36 above, and further in view of Wang et al. (U.S. Pat. 6,364,956).

The difference not yet discussed is the use of a shutter (Claim 23).

Regarding claim 23, Wang teach utilizing a shutter to selectively block at least a portion of the a material expelled from at least on of the deposition devices. (See Abstract)

The motivation for utilizing the features of Wang is that it allows for production of a gradient film. (See Abstract)

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Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to have utilized a shutter as taught by Wang because it allows for producing gradient films.

Claim 37 are rejected under 35 U.S.C. 103(a) as being unpatentable over Barnett et al. in view of Montcalm et al. as applied to claims 1, 2, 5, 6, 9, 15, 16, 20, 21, 24, 31, 32, 34, 35 and 36 above, and further in view of Surampudi et al. (U.S. Pat. 5,773,162).

The difference not yet discussed is the material of the cathode. (Claim 37)

Regarding claim 37, Surampudi et al. teach that the material for the cathode material of a fuel cell can be sputtered platinum, (Column 12 lines 63-68)

The motivation for utilizing the features of Surampudi et al. is that it allows production of a fuel cell. (Column 12 lines 63-68)

Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to have utilized the features of Surampudi et al. because it allows for production of fuel cell.

Allowable Subject Matter

Claims 12-14 and 27-29 objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

Claims 12-14 and 27-29 are allowable over the prior art of record because the prior art of record does not teach the method as claimed including where the deposition characteristic comprises at least composition gradient profile and at least one morphological gradient profile.

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Conclusion

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Tsai et al. "Sutter deposition of cermet fuel electrodes for solid oxide fuel cells", J. Vac. Sci. Techno. A 13(3), May/Jun 1995, pp. 1073-1077. This reference teaches sputtering Ni-YSZ films by sputter deposition to form a porous layer. It is noted that porosity of the films is characterized by density. (see Page 1074 for example)

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Rodney G. McDonald whose telephone number is 571-272-1340. The examiner can normally be reached on M- Th with Every other Friday off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nam X. Nguyen can be reached on 571-272-1342. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Rodneý G. McDonald Primary Examiner Art Unit 1753

RМ

November 29, 2006